

Notice of References Cited

Application/Control No.

10/552,132

Applicant(s)/Patent Under
Reexamination
WON ET AL.

Examiner

JASON PROCTOR

Art Unit

2123

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0014146	01-2003	Fujii et al.	700/121
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Yasuhiro Ugai et al., "Reduced Process Method for Thin-Film-Transistor Liquid-Crystal Display (TFT-LCD) with Dry-Etching Tapered ITO Data Bus Lines", 1996, Jpn. J. Appl. Phys., Vol 35, pages 1027-1030
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.